

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named

Inventor : Benjamin Y.H. Liu

Appln. No.: 10/769,011

Filed : January 30, 2004

For : HIGH-PERFORMANCE AND MULTI-
LIQUID-PERCUSOR VAPORIZATION
IN SEMICONDUCTOR THIN FILM
DEPOSITION

Docket No.: M419.12-0043

Group Art Unit: 1792

Examiner: Bueker, Richard R.

**AMENDMENT ACCOMPANYING REQUEST
FOR CONTINUED EXAMINATION**

**FILED ELECTRONICALLY
DECEMBER 4, 2008**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment responds in part to the Official Action relating to claims 2-6, 12 and 22-27 dated August 5, 2008. It also responds in part in relation to newly submitted claims to the Official Action dated September 7, 2008.

Please amend the above-identified application as follows.